

Form 1449*	Atty. Docket No.: 303.367US2	Serial No. Unknown
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Applicant: Paul A. Farrar et al.	
	Filing Date: Herewith	Group: Unknown

1986 U.S. PTO  
09/930521  
08/15/01

## U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>mm</i>	3,932,226	01/13/1976	Klatskin, J.B., et al.	204	16	12/06/74
	4,503,451	03/01/1985	Lund, C.A., et al.	257	374	07/30/82
	4,670,297	06/02/1987	Lee, K., et al.	427	91	06/21/85
	4,857,481	08/15/1989	Tam, G., et al.	437	182	03/14/89
	4,939,567	07/03/1990	Kenney, D.M.	357	42	01/30/89
	4,977,439	12/11/1990	Esquivel, A., et al.	357	49	04/03/87
	5,158,986	10/27/1992	Cha, S.W., et al.	521	82	04/05/91
	5,202,754	04/13/1993	Bertin, et al.			
	5,227,658	07/13/1993	Beyer, K.D., et al.	257	522	10/23/91
	5,232,866	08/03/1993	Beyer, K.D., et al.	437	62	10/23/91
	5,268,315	12/07/1993	Prasad, J.S., et al.	437	31	09/04/92
	5,270,261	12/14/1993	Bertin, et al.			
	5,308,440	05/03/1994	Chino, T., et al.	156	664	09/02/92
	5,334,356	08/02/1994	Baldwin, D.F., et al.	422	133	08/24/92
	5,349,743	09/01/1994	Grader, G.S., et al.	29	602.1	05/02/91
	5,382,832	01/17/1995	Buti, T.N., et al.	257	773	10/04/93
	5,396,093	03/07/1995	Lu	257	306	08/12/94
	5,410,169	04/25/1995	Yamamoto, T., et al.	257	301	02/22/93
	5,436,173	07/25/1995	Houston	437	21	
	5,438,009	08/01/1995	Yang, M.T., et al.	437	52	04/02/93
	5,497,017	03/05/1996	Gonzales, /.	257	306	01/26/95
	5,504,357	04/02/1996	Kim, J.S., et al.	257	306	06/30/94
	5,539,227	07/23/1996	Nakano, H.	257	276	08/02/95
	5,593,921	01/14/1997	Chen, F.E., et al.	437	195	05/09/95
	5,705,425	01/06/1998	Miura, T., et al.	437	182	04/26/96
	5,747,867	05/05/1998	Oppermann, K.	257	507	12/15/95
	5,798,544	08/25/1998	Ohya, S., et al.	257	296	05/13/94
	5,892,707	04/06/1999	Noble, W.	365	149	04/25/97
	5,930,596	07/27/1999	Klose, H., et al.	438	98	03/07/95
	5,930,668	07/27/1999	Gardner, D.S.	438	624	12/19/94

## FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes   No
<i>mm</i>	2179787	03/11/1987	United Kingdom	H01L	21/74	

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

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\*Substitute Disclosure Statement Form (PTO-1449)

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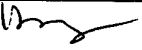
## OTHER DOCUMENTS

\*\*Examiner  
Initial

(Including Author, Title, Date, Pertinent Pages, Etc.)

jc986 U.S. PTO  
09/930521  
08/15/01

lm	Abidi, "Large Self-Suspended Inductors on Silicon and Their Use in 2-mu m CMOS RF Amplifier", <u>IEEE Electron Device Letters</u> , Vol. 17, No. 9, 246-48, (1993)
	Burghartz, et al., "Integrated RF and Microwave Components in BiCMOS Technology", <u>IEEE Trans. Electron Devices</u> , Vol. 43, No. 9, 1559-70, (1996)
	Burghartz, et al., "Multi-level Spiral Inductors Using VLSI Interconnect Technology", <u>IEEE Electron Device Letters</u> , Vol. 17, No. 9, 428-30, (1996)
	Jin, C., et al., "Porous Xerogel Films as Ultra-low Permittivity Dielectrics for ULSI Interconnect Applications", <u>Conference Proceedings ULSI XII - 1997 Materials Research Society</u> , pp. 463-469, (1997)
	Meyer, et al., "Si IC-Compatible Inductors and LC Passive Filters", <u>IEEE Journal of Solid State Circuits</u> , Vol. 25, No. 4, 1028-31, (1990)
	Miller, R.D., et al., "Low Dielectric Constant Polyimides and Polyimide Nanofoams", <u>Seventh Meeting of the DuPont Symposium on Polymides in Microelectronics</u> , pp. 443-473, (September 1996)
↓	Ting, C.H., "Methods and Needs for Low K Material Research", <u>Materials Research Society Symposium Proceedings, Volume 381, Low-Dielectric Constant Materials -- Synthesis and Applications in Microelectronics</u> , Lu, T.M., et al., (eds.), San Francisco, CA, 3-17, (April 17-19, 1995)

Examiner		Date Considered	02-21-02
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Sheet 1 of 1

Form 1449\*

Atty. Docket No.: 303.367US2

Serial No. 09/930,521

INFORMATION DISCLOSURE STATEMENT  
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Applicant: Paul A. Farrar et al.

Filing Date: August 15, 2001

Group: Unknown

## U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Am</i>	4,461,041	07/17/1984	Dobrovolny, P.	455	328	01/05/83
	5,734,676	03/31/1998	Dingsor, A.	375	222	05/24/96
	5,760,456	06/02/1998	Grzegorek, A.Z., et al.	257	531	12/21/95
	5,874,770	02/23/1999	Saia, R.J., et al.	257	536	10/10/96
	5,892,425	04/06/1999	Kuhn, W.B., et al.	336	200	04/10/97
	6,081,988	07/04/2000	Pluymers, B.A., et al.	29	601	04/30/98
	6,239,684	05/29/2001	Farrar, P.A., et al.	336	200	12/14/99

## FOREIGN PATENT DOCUMENTS

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## OTHER DOCUMENTS

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